

Notice of References Cited

Application/Control No.

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Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

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Art Unit

1624

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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FOREIGN PATENT DOCUMENTS

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	N	WO 03/042242 /	05-2003	WIPO	Reiter, et al.	
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